Attorney Docket No.: VLSI-3234 (PHA 780016)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE stent Application Hubbard 09/520,686 Group Art Unit: 3/7/00 Examiner:

Title:

Inventor(s):

Serial No.:

Filed:

WAFER TARGET DESIGN AND METHOD FOR DETERMINING CENTROID OF WAFER

TARGET

## Form 1449

## **U.S. Patent Documents**

Examiner Initial	No.	Patent No.	Date	Patentee	Class	Sub- class	Filing Date
par /	A	4,253,112	2/24/81	Doemens	358	101	5/21/79
101/	В	5,760,484	6/2/98	Lee et al.	257	797	2/11/97
14/	С	4,880,309	11/14/89	Wanta	356	401	4/14/87
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Foreign Patent or Published Foreign Patent Application

Examiner	1	Document	Publication	Country or		Sub-	Tran	slation
Initial	No.	No.	Date	Patent Office	Class	class		No
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**Other Documents** Examiner Initial No. Author, Title, Date, Place (e.g. Journal) of Publication PATENT ABSTRACTS OF JAPAN, vol. 017, no. 272 (E-1371), 26 May 1993 (1993-05-26) -& JP 05 013306 A (Fujitsu Ltd), 22 January 1993 (1993-01-22) abstract; figures Examine? Date Considered

Examiner: Initial citation considered. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.